

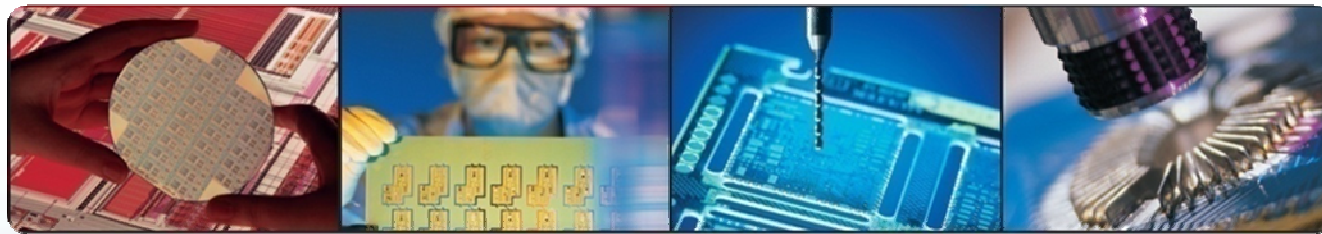
Hannover Messe 2010

Comparison of Key Factors for Successful Commercialization of Micromachined Pressure, Inertial and Flow Sensors

Dr. Thomas Link

Application Centre
MicroMountains Applications

April 20, 2010



- We are service provider for research, development, and manufacturing in Microsystems Technology
- Accelerating the transfer of technologies and know-how to industrial partners:

Development Process...





...the Application Centre represent extensive experience and know-how of more than 500 technology experts.

Benefit for industrial companies

1. fast and cost-efficient access to micro technologies
2. just one contact
3. "best solutions" concept

Benefit for R&D-institutes:

1. Industrial requests
2. Initiate projects
3. Project Coordination

TECHNOLOGIE

- S**Thin film- & Thick film
- Photolithography,
 - Wet & Dry Etching
 - Bonding, PVD, CVD, Oxidation, Epitaxy
 - Molding
 - 3D-MID
 - Precision Micromachining
 - Surface machining
 - Laser structuring
 - Flexible substrates
 - ...

ENGINEERING

- CAD & Design
- Modeling & Simulation
- Assembly & Packaging
- Measurement & Test
- Analysis
- Circuit Design (ASIC, SMD)
- Embedded Systems
- System integration
- ...

MATERIALS

Silicon, Polymers
Metals, Ceramics
Glass, ...

SYSTEMS, e.g.

- Multi-sensoric
- Multi-axial
- Dosage ($\mu\text{l-nl}$)
- Lab-on-Chip
- Data Logging systems
- Gas Sensory Systems
- ...

Sensors /

- Actors**
- Sensors, e.g. for angle, inclination, orientation, distance, position, force, pressure, acceleration, vibration, flow of fluids and gases
- **Micro actors, e.g.** pumps, switches, valves, dosage
 - **Micro-Energy Harvester** mechanical, thermo- electrical
-

Project Management

... time and cost efficient project management of heterogeneous projects

Technology and Market Analysis

... continuous monitoring of recent and future technologies and market requests

Innovation Workshop

... supporting your strategic planning with future technologies

Business partners

... identify and incorporate partners for the development and production chain

Financing

... incorporate partners and concepts for financing your next project

Patent Research

... supporting patent research with technological expertise

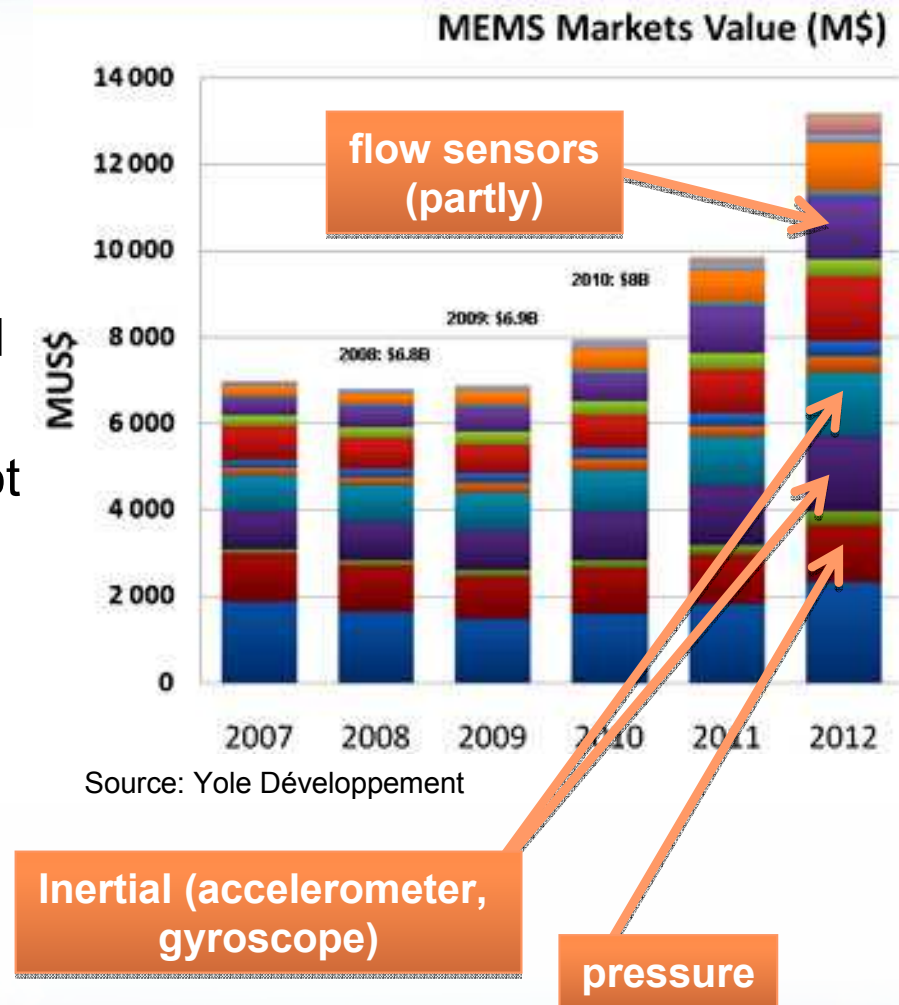
Technology and Know-how Transfer

... transferring processes and product specific know-how to our customer

Comparison of Key Factors for Successful Commercialization

- Why to compare pressure, flow and inertial sensors
 - Some of the most successful MEMS based sensors today
 - ... they differ, not only in their measured variable
 - ... and successful MEMS sensors do not only have to use „silicon material and clean rooms“

- Benefits from miniaturisation:
 1. higher performance
 2. new functionalities
 3. lower cost



Miniaturised / Micromachined Pressure Sensors

- Pressure Sensors
 - measuring the pressure (force per unit area)
 - absolute, relative, differential pressure
 - often using membranes
 - piezoresistive or capacitive principles
- General Characteristics
 - Sensor has physical contact to measured variable
 - Complexity (e.g. of piezoresistive) is mid / low, requires no complex readout electronics, sensor often base on standard technologies
 - today approx. 5000 manufacturer exists world wide (macro/micro technologies)

Example of micromachined piezoresistive pressure sensor

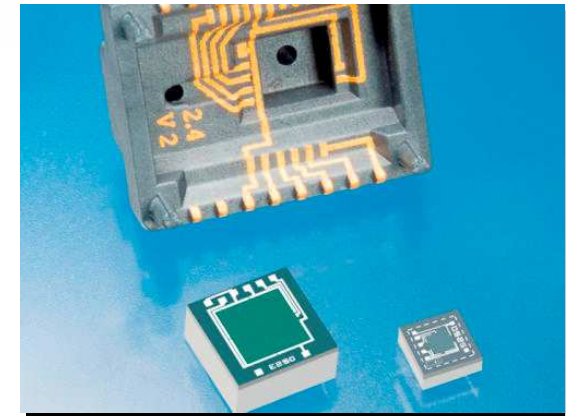
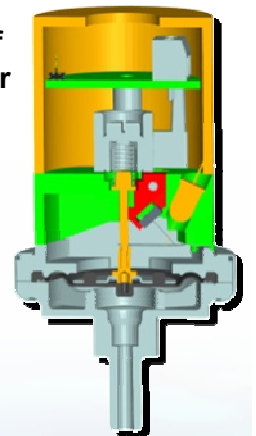


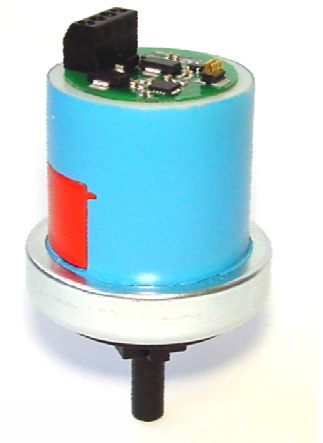
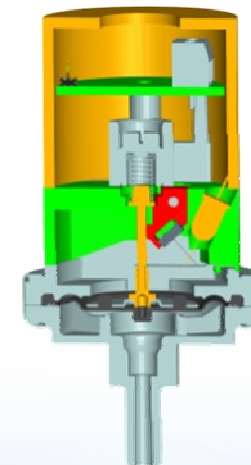
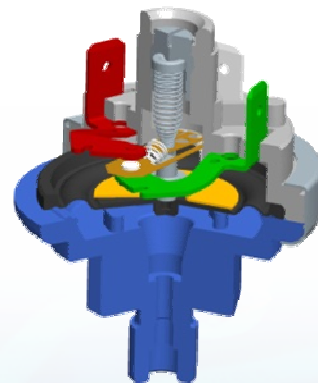
Image: www.harting-mitronics.ch

Example of low pressure sensor



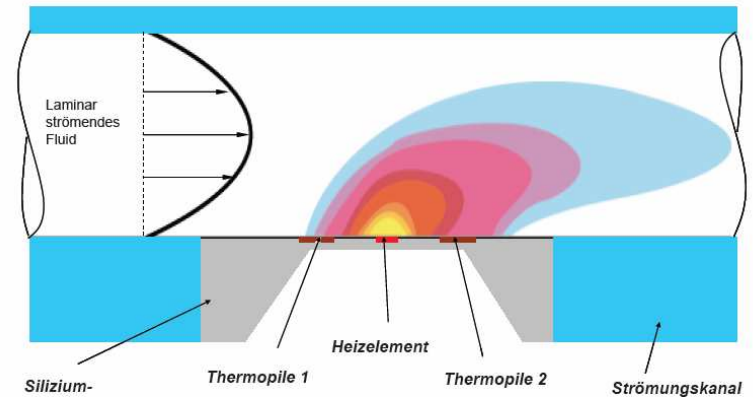
Example: Low Pressure Sensors at MicroMountains Applications

- Industrial low pressure sensor developed at the application center
 - elastomeric membrane as basis for continuous detection of deformation
 - switch in the low pressure range (threshold 100mbar) based on optical measurement principle and discrete low cost components
 - partners: Beck Druckmesstechnik GmbH, HSG-IMIT, IMTEK, MicroMountains Applications



Miniaturised / Micromachined Flow Sensors

- Flow Sensors
 - measuring the flow of gases or fluids
 - often using thermal (anemometer) principle
- General Characteristics
 - physical contact to measured variable (aspects as flow control, protection against corrosion)
 - complexity (e.g. of anemometer) is mid / low, requires no complex readout electronics, based on standard technologies
 - today approx. 4000 manufacturer exists world wide (macro/micro technologies)



Micromachined acceleration and inclination sensors

- accelerometer
 - measuring inertial force (in relation to earth gravity called inclinometer)
 - translational or rotational
 - often using spring-mass-damper systems
 - piezoresistive, capacitive or piezoelectric principle

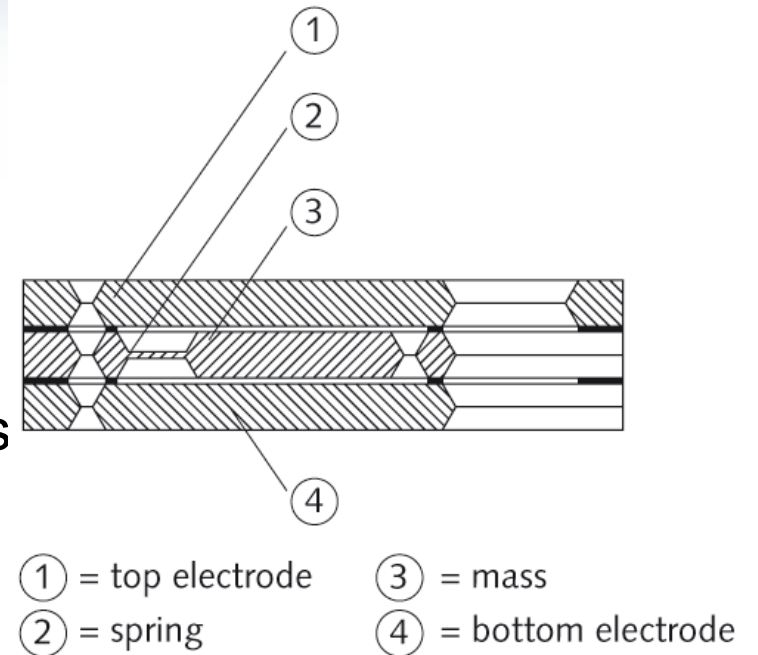


Image: www.kistler.com

- General Characteristics
 - no physical contact to „media“, hermetical packaging possible
 - complexity is mid
 - today approx. 1000 manufacturer exists world wide (macro/micro technologies)

Accelerometer Example
(for movements and inclination)



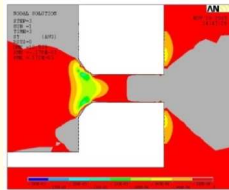
MEMS Crash-Test-Sensor

**Piezoresistive MEMS acceleration sensors
involved in crash test for the car development**

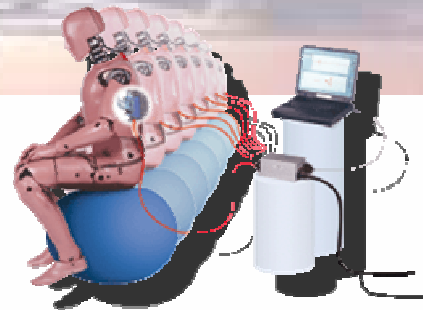


- Measurement range: up to 1000g
- Overload up to 10.000g
- High sensitivity and linearity
- Small and light weight (< 1 gram)
- Non-linearity: < 0.3 %
- Dynamic range: <25mg...>500g (> 20000)

Size: < 4 x 4mm²



References of Kistler IGeL GmbH



**See more at
Hall 2, Stand C24
Hall 6, H16, E4**

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High performance 360°- Inclinometer



Inclinometer for high precision and low cost based on innovative PCB hybrid technology



**360 ° range full range
high linearity**

**capacitive inclination - sensor
custom interfaces and
calibrations**

OEM versions available



Manufacturing and Sales:

**2E mechatronic GmbH & Co. KG
Kirchheim**



First Products:

**Laser distance meter from Leica
Geosystems**



See more at

Hall 6, H16, E4

Hall 2, Stand C24

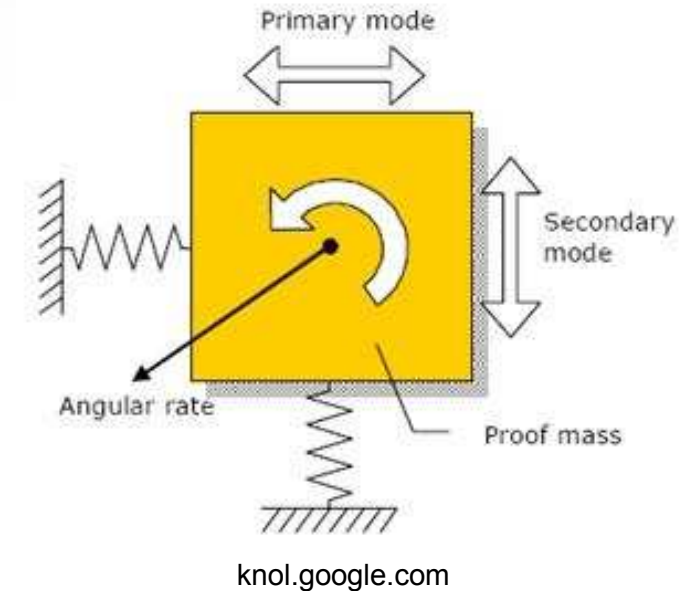
Evaluation kit available:

www.2e-mechatronic.de

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- Gyroscopes
 - Measuring rotational velocity
 - often used coupled spring-mass-damper systems by Coriolis effect
 - capacitive principle
- General Characteristics
 - no physical contact to „media“ (hermetical packaging)
 - Complexity: high, due to measuring principle and technological requirements
 - today approx. 20 manufacturer world wide (macro/micro technologies)

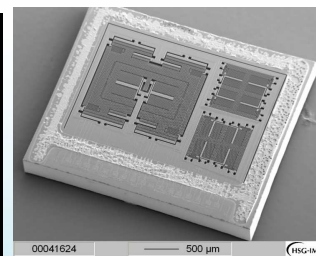
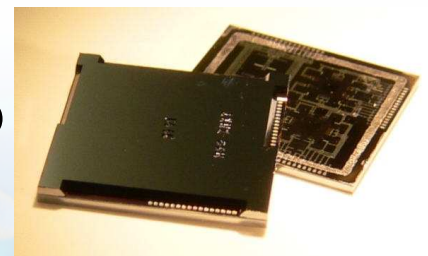
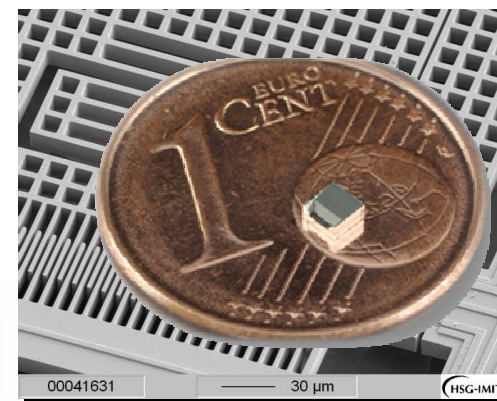
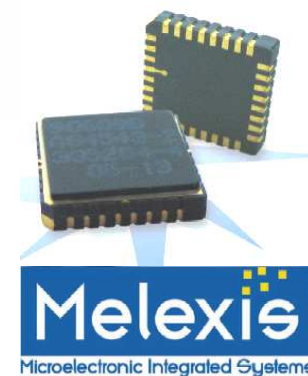
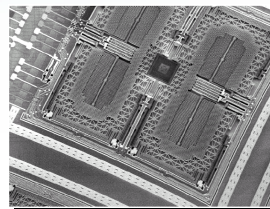


MEMS Gyroscope Applications (ST Microelectronics)



Example: MEMS Gyroscopes at MicroMountains Applications

- Low cost, high-performance programmable angular rate sensor for automotive market
 - Applications: Navigation (dead reckoning), Robots, Advanced driving assistant systems (ADAS)
- Latest development
 - One of the world's smallest MEMS Gyroscope
 - DIE size: $1,8\text{mm}^2$, MEMS Structure: $800 \times 600 \mu\text{m}^2$
 - Multi-axis MEMS Gyroscope on one chip



MicroSystemTechnology is your way - MicroMountains your partner !



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